

High-voltage engineering

E. Gaxiola

CERN, Geneva, Switzerland

Abstract

High-voltage engineering covers the application, the useful use and proper working of high voltages and high fields. Here we give some introductory examples, i.e., ‘septa’ and ‘kicker’ at the Large Hadron Collider (14 TeV), the Super Proton Synchrotron (450 GeV) and the Proton Synchrotron (26 GeV) accelerators as found at the European Organization for Nuclear Research (CERN) today.

We briefly cover the theoretical foundation (Maxwell equations) and aspects of numerical field simulation methods. Concepts relating to electrical fields, insulation geometry and medium and breakdown are introduced. We discuss ways of generating high voltages with examples of AC sources (50/60 Hz), DC sources, and pulse sources.

Insulation and breakdown in gases, liquids, solids and vacuum are presented, including Paschen’s law (breakdown field and streamer breakdown). Applications of the above are discussed, in particular the general application of a transformer.

We briefly discuss measurement techniques of partial discharges and loss angle $\tan(\delta)$.

The many basic high-voltage engineering technology aspects — high-voltage generation, field calculations, and discharge phenomena — are shown in practical accelerator environments: vacuum feed through (triple points), breakdown field strength in air 10 kV/cm, and challenging calculations for real practical geometries.

Exceptionally, the series editor decided that this contribution could be published in the form of a reproduction of the author’s transparencies.

High Voltage Engineering

Enrique Gaxiola

Many thanks to the Electrical Power Systems Group, Eindhoven University of Technology, The Netherlands
& CERN AB-BT Group colleagues

Introductory examples

Theoretical foundation and numerical field simulation methods

Generation of high voltages

Insulation and Breakdown

Measurement techniques

CAS on Small Accelerators

Introduction E.Gaxiola:

Studied Power Engineering

Ph.D. on Dielectric Breakdown in Insulating Gases;

Non-Uniform Fields and Space Charge Effects

Industry R&D on Plasma Physics / Gas Discharges

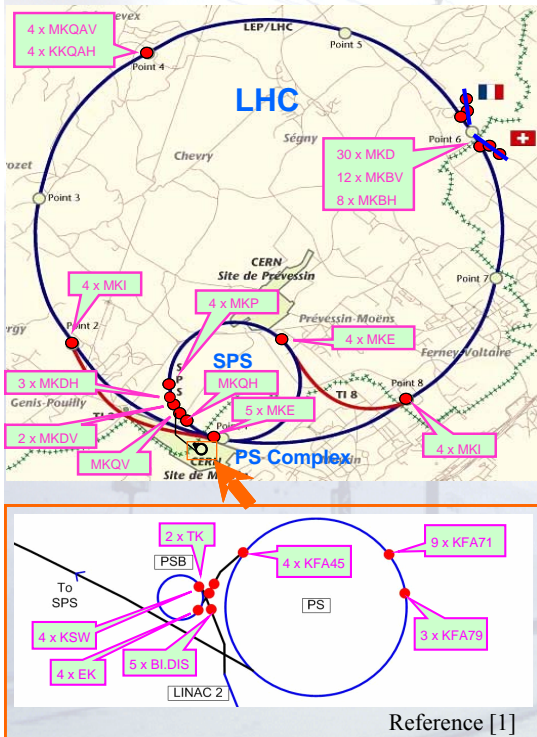
CERN Accelerators & Beam, Beam Transfer,

Kicker Innovations:

- Electromagnetism
- Beam impedance reduction
- Vacuum high voltage breakdown in traveling wave structures.
- Pulsed power semiconductor applications

CAS on Small Accelerators

CERN Septa and Kicker examples



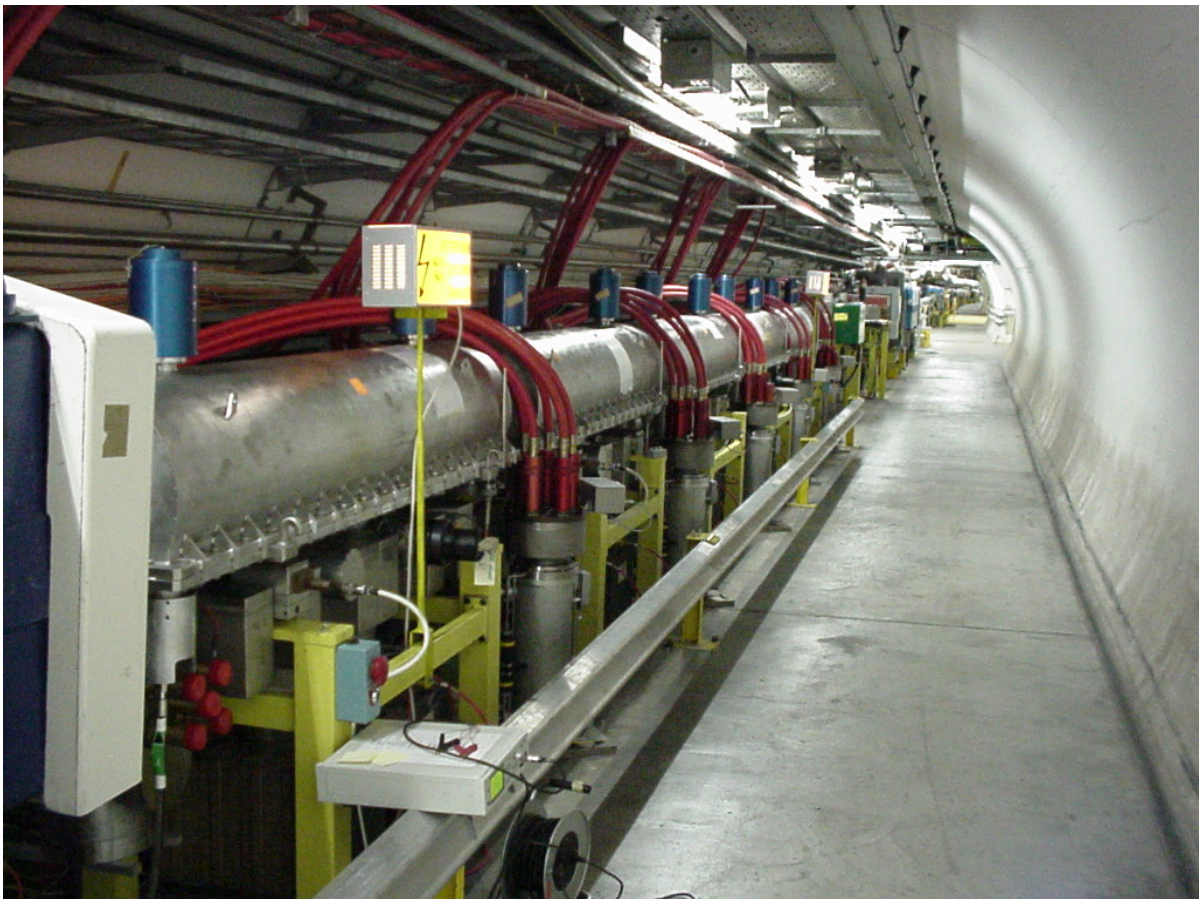
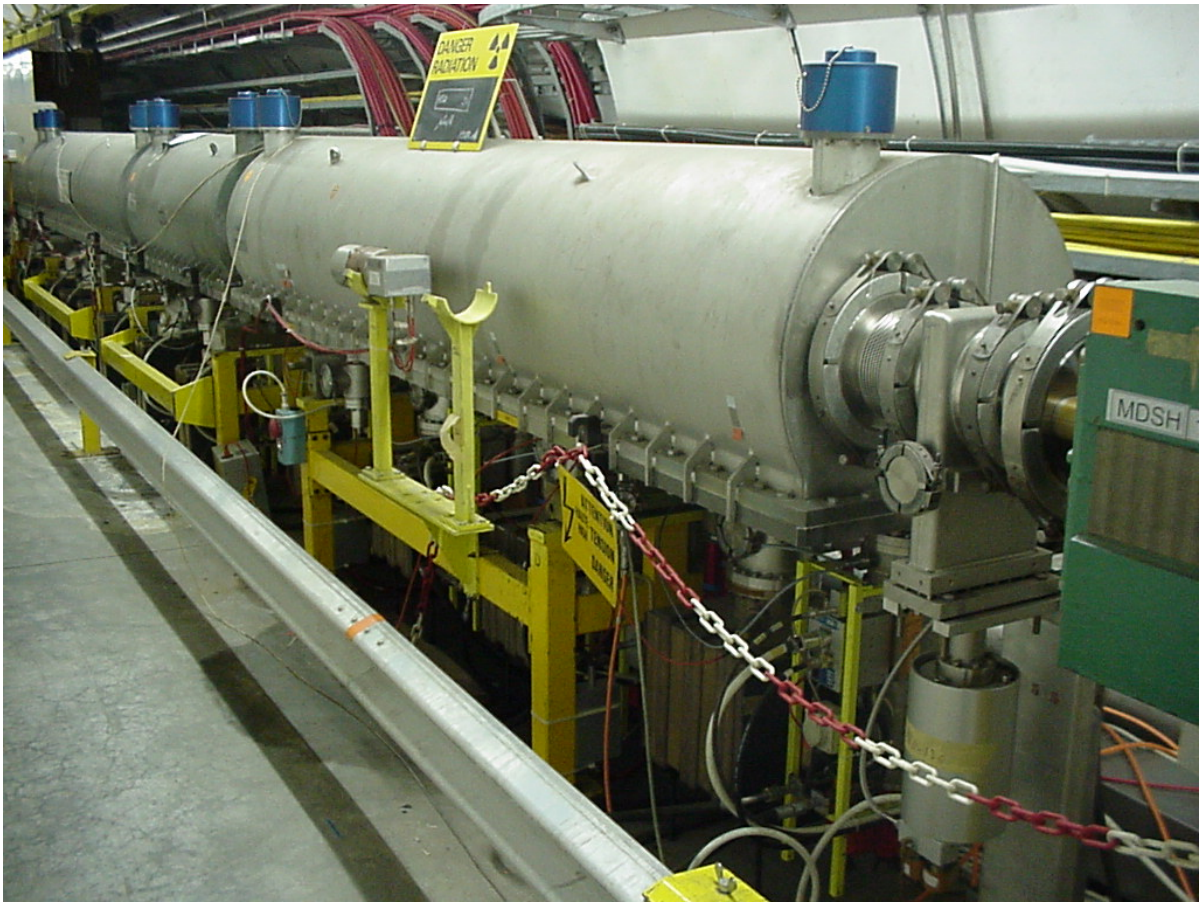
- Large Hadron Collider
14 TeV
- Super Proton Synchrotron
450 GeV
- Proton Synchrotron
26 GeV

Septum: $E \leq 12 \text{ MV/m}$ $T = \text{d.c.}$
 $l = 0.8 - 15 \text{ m}$

Kicker: $V = 80 \text{ kV}$
 $B = 0.1 - 0.3 \text{ T}$ $T = 10 \text{ ns} - 200 \mu\text{s}$
 $l = 0.2 - 16 \text{ m}$

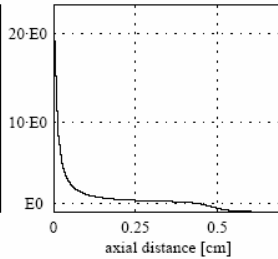
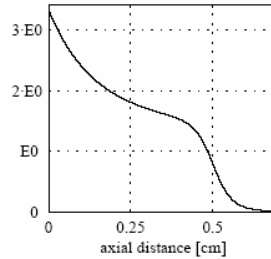
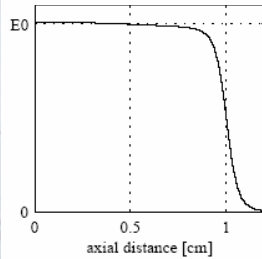
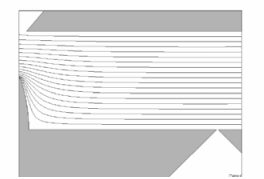
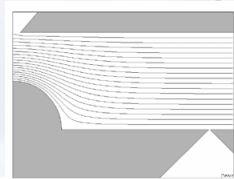
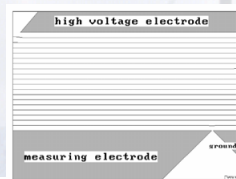
RF cavities: High gradients, $E \leq 150 \text{ MV/m}$



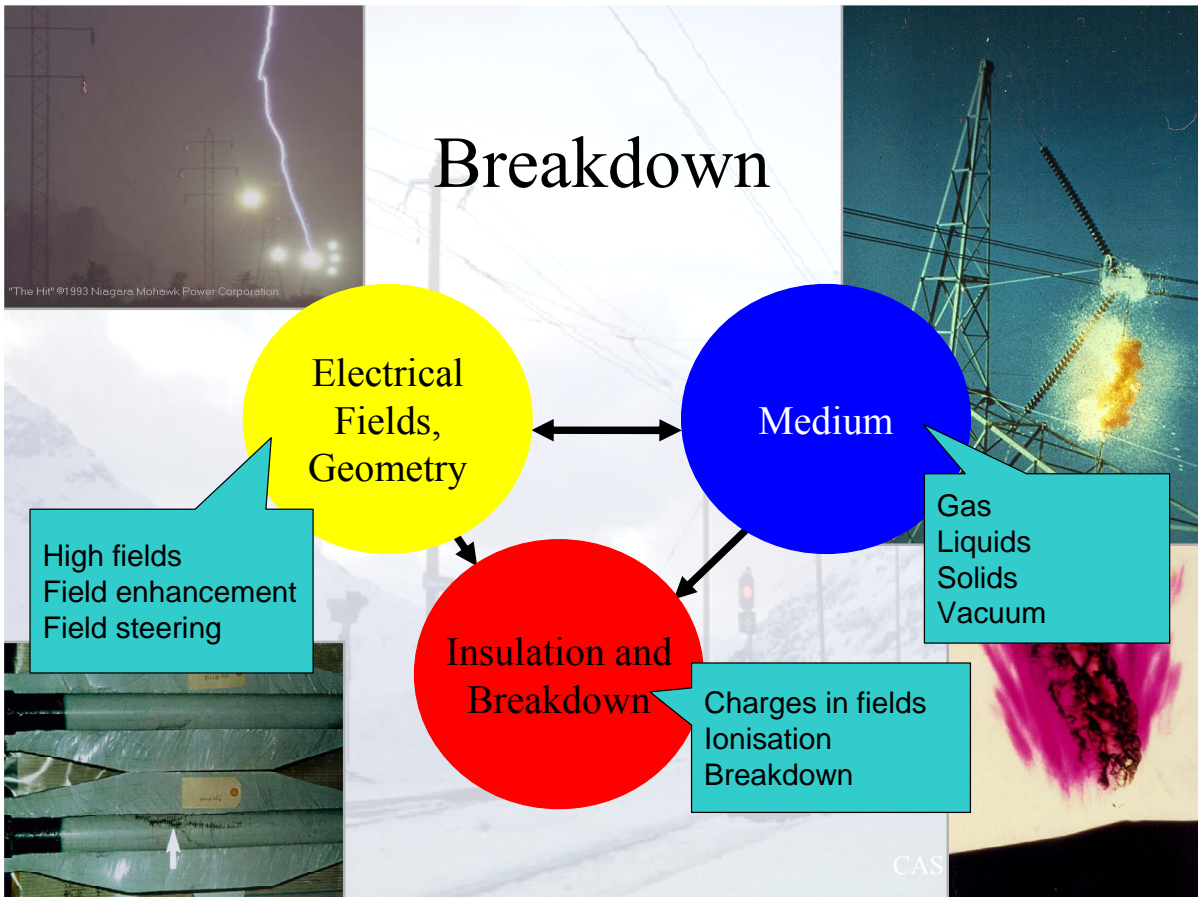


- Maxwell equations for calculating Electromagnetic fields, voltages, currents

- Analytical
- Numerical



all Accelerators



NUMERICAL FIELD SIMULATION METHODS

- **CSM** (Charge Simulation Method): (Coulomb)

Electrode configuration is replaced by a set of discrete charges

- **FDM** (Finite Difference Method):

Laplace equation is discretised on a rectangular grid

- **FEM** (Finite Element Method): Vector Fields (Opera, Tosca), Ansys, Ansoft

Potential distribution corresponds with minimum electric field energy

($w = \frac{1}{2} \epsilon E^2$)

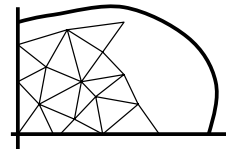
- **BEM** (Boundary Element Method): IES (Electro, Oersted)

Potential and its derivative in normal direction on boundary are sufficient

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Procedure FEM

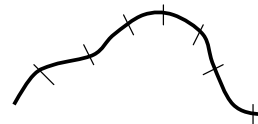
1. Generate mesh of triangles:
2. Calculate matrix coefficients: $[S]_{ij} = (\nabla \alpha_i \cdot \nabla \alpha_j) A$
3. Solve matrix equation:
$$\begin{bmatrix} S_{kf} & S_{kp} \end{bmatrix} \begin{bmatrix} U_f \\ U_p \end{bmatrix} = 0$$
4. Determine equipotential lines and/or field lines



Procedure BEM

1. Generate elements along interfaces
2. Generate matrix coefficients: $H_{ij} = \int_{S_j} \frac{\partial \ln r_i}{\partial n} ds$, $G_{ij} = \int \ln r_i ds$
3. Solve matrix equation:
$$\sum_{j=1}^n (H_{ij} - \pi \delta_{ij}) U_j = \sum_{j=1}^n G_{ij} Q_j$$
4. Determine potential on arbitrary position:

$$U(x_0, y_0) = \frac{1}{2\pi} \left(\sum_{j=1}^n U_j \int_{S_j} \frac{\partial \ln r}{\partial n} ds - \sum_{j=1}^n Q_j \int_{S_j} \ln r ds \right)$$



Generation of High Voltages

- AC Sources (50/60 Hz)

High voltage transformer (one coil; divided coils; cascade)
 Resonance source (series; parallel)

- DC Sources

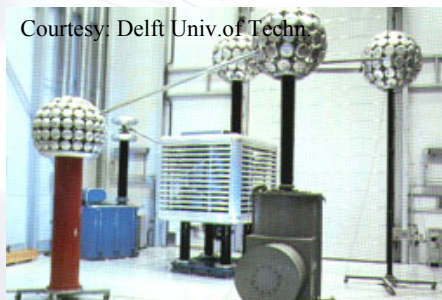
Rectifier circuits (single stage; cascade)
 Electrostatic generator (van de Graaff generator)

- Pulse sources

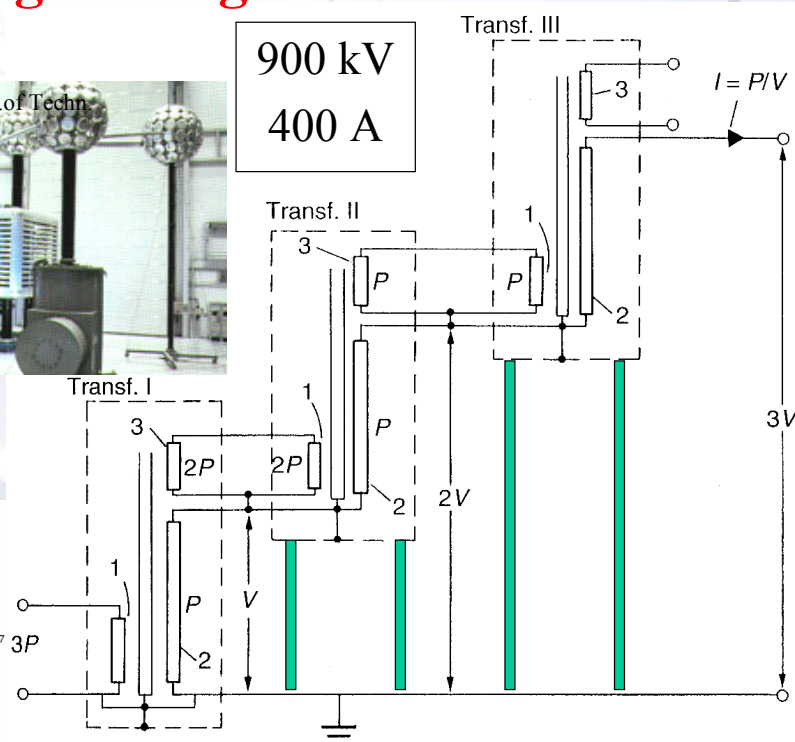
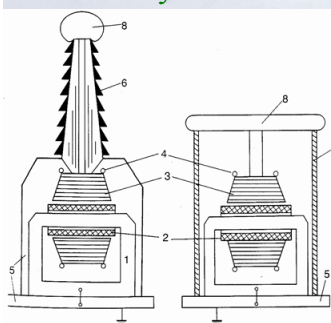
Pulse circuits (single stage; cascade; pulse transformer)
 Traveling wave generators (PFL; PFN; transmission line transformer)

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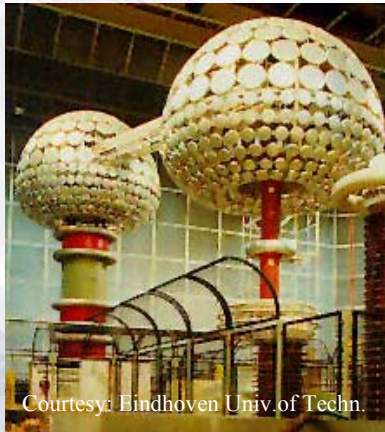
Cascaded High voltage transformer



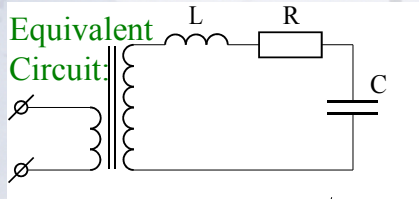
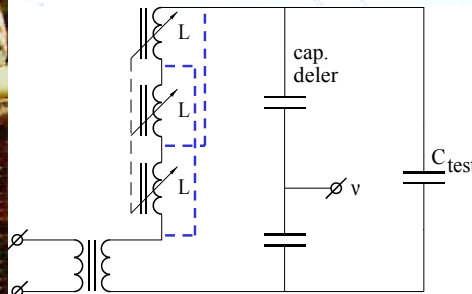
- 1: primary coil
- 2: secondary coil
- 3: tertiary coil



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Resonance Source



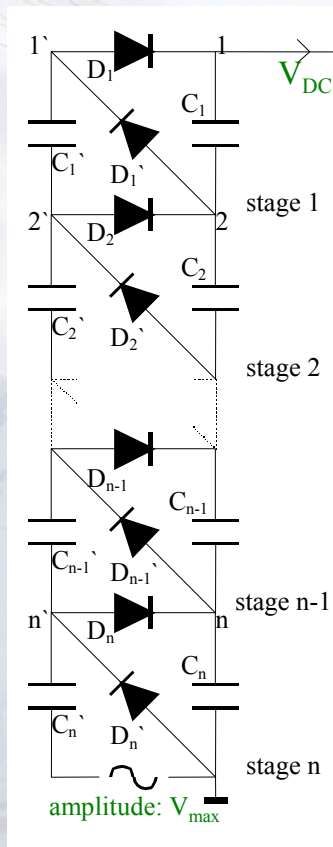
$$|H(\omega)| = \frac{Q \omega_0 / \omega}{\sqrt{1 + Q^2 (\omega_0 / \omega - \omega / \omega_0)^2}}$$

$$\omega_0 = \frac{1}{\sqrt{LC}} \quad \text{and} \quad Q = \frac{1}{R} \sqrt{\frac{L}{C}}$$

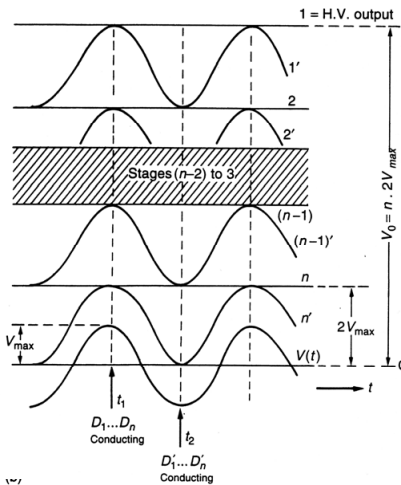
- + Waveform: almost perfect sinusoidal
- + Power: 1/Q of "normal" transformer
- + Short circuit: $Q \rightarrow 0$ results in $V \rightarrow 0$
- No resistive load

900 kV
100 mA

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Cascaded Rectifier (Greinacher; Cockcroft - Walton)



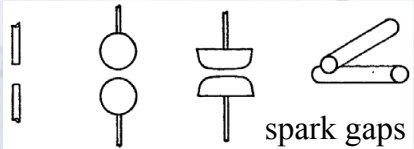
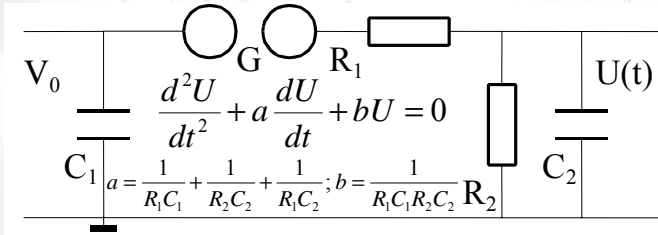
$$V_{DC} = 2nV_{max}$$

Reduce δV ($\sim n^2$) and ΔV ($\sim n^3$) by:
 larger C's (more energy in cascade)
 higher f (up to tens of kilohertz)

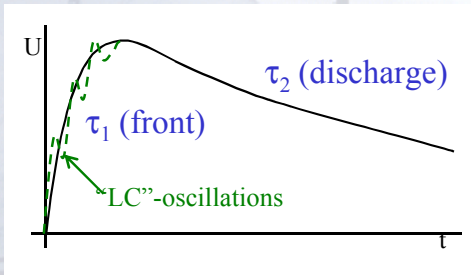
Voltage: 2 MV

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Single-Stage Pulse Source



60 kV
1 kA



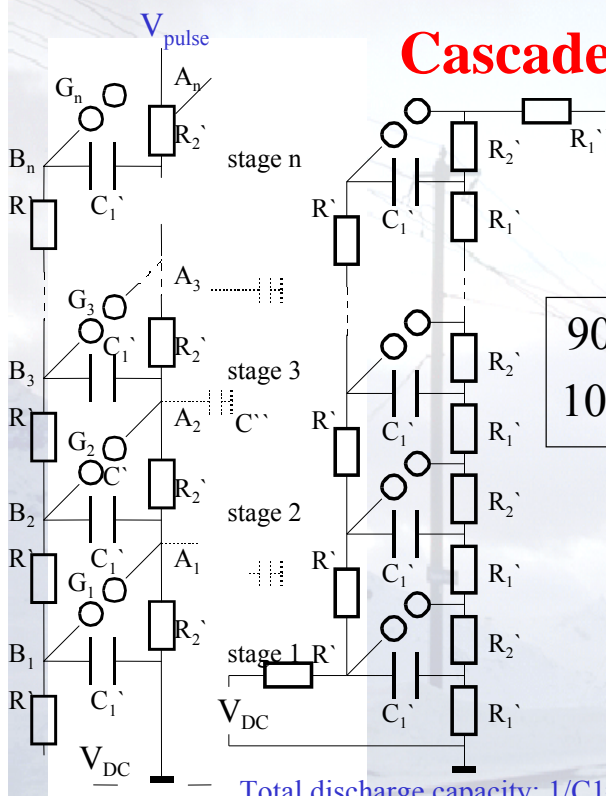
$$U(t) = V_0 (e^{-t/\tau_2} - e^{-t/\tau_1})$$

if $C_1 \gg C_2$ and $R_2 \gg R_1$
rise time: $\tau_1 = R_1 C_2$
discharge time: $\tau_2 = R_2 C_1$

Standard lightning surge pulse: 1.2 / 50 μ s

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Cascade Pulse Source (Marx Generator)



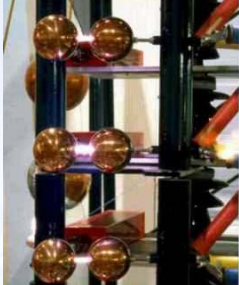
(Marx Generator)

$$V_{pulse} = n \cdot V_{DC}$$

900 kV
100 mA

Total discharge capacity: $1/C_1 = \sum 1/C_1'$
Front resistance: $R_1 = R_1'' + \sum R_1'$
Discharge resistance: $R_2 = \sum R_2'$

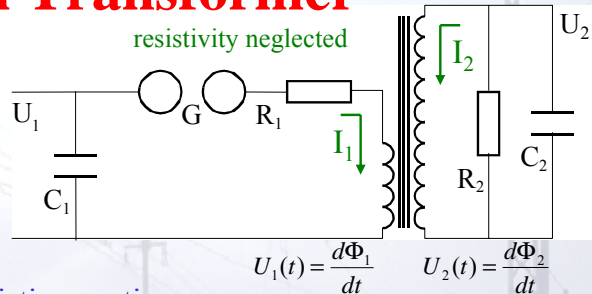
R_1' : front resistor
 R_2' : discharge resistor



Voltage: 300 kV

Pulse Source with Transformer

primary: $L_1 C_1 \frac{d^2 I_1}{dt^2} - M C_1 \frac{d^2 I_2}{dt^2} + I_1 = 0$
 secondary: $L_2 C_2 \frac{d^2 I_2}{dt^2} - M C_2 \frac{d^2 I_1}{dt^2} + I_2 = 0$



Eigen frequencies from characteristic equation:

$$\begin{pmatrix} L_1 C_1 & -M C_1 \\ -M C_2 & L_2 C_2 \end{pmatrix} \begin{pmatrix} i_1 \\ i_2 \end{pmatrix} = \frac{1}{\omega^2} \begin{pmatrix} i_1 \\ i_2 \end{pmatrix} \Rightarrow \left(L_1 C_1 - \frac{1}{\omega^2} \right) \left(L_2 C_2 - \frac{1}{\omega^2} \right) - M^2 C_1 C_2 = 0$$

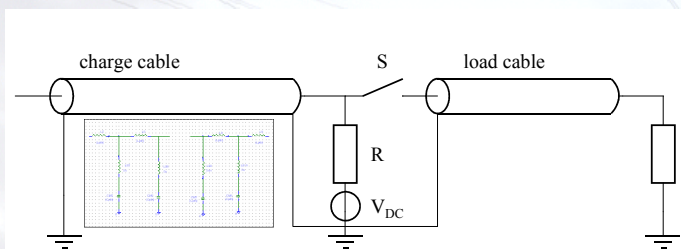
Approximation: transformer almost ideal: $k = M / \sqrt{L_1 L_2} \rightarrow 1$

$$\omega_1 \approx \frac{1}{\sqrt{L_1 C_1 + L_2 C_2}} = \frac{1}{\sqrt{L_1 (C_1 + C_2')}} \quad \text{slow oscillation}$$

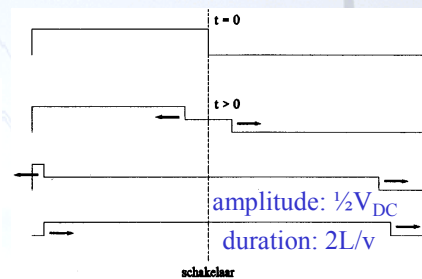
$$\omega_2 \approx \frac{1}{\sqrt{1-k^2} \sqrt{\frac{1}{L_1 C_1} + \frac{1}{L_2 C_2}}} = \frac{1}{\sqrt{L_{eq} (C_1 // C_2')}} \quad \text{fast oscillation}$$

CAS on Small Accelerators

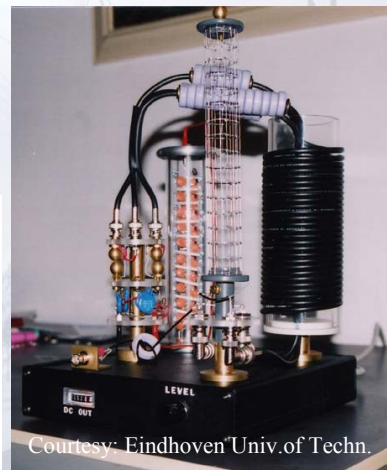
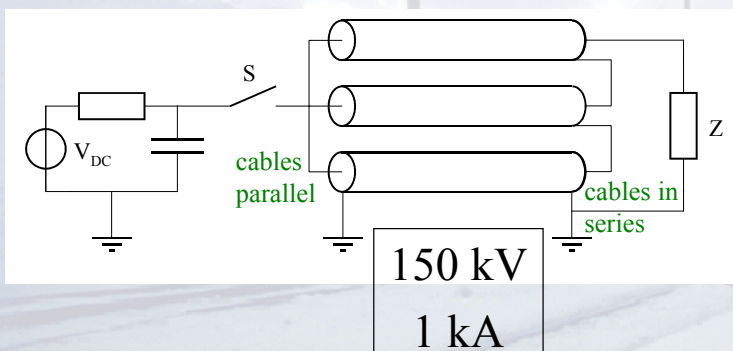
Pulse Forming Line / Network



80 kV, 10 kA, T=20ns - 10µs



Transmission Line Transformer



Courtesy: Eindhoven Univ. of Techn.

CAS on Small Accelerators

Insulation and Breakdown

- In Gases

Ionisation and Avalanche Formation
Townsend and Streamer Breakdown
Paschen Law: Gas Type
Breakdown Along Insulator
Inhomogeneous Fields, Pulsed Voltages, Corona

- Insulating Liquids

- Solid Insulation

Breakdown types, Surface tracking, Partial discharges, Polarisation, $\tan \delta$

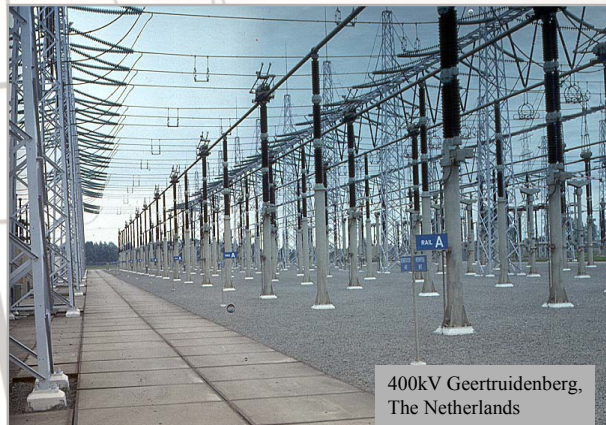
- Vacuum Insulation

Applications, Breakdown, Cathode Triple-Point, Insulator Surface Charging, Conditioning

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400kV



400kV Geertruidenberg, The Netherlands



800kV South Africa



1st free electron

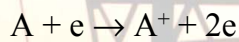
- Cosmic radiation
- Shortwave UV
- Radio active isotopes

In air:
 $\approx 2.5 \times 10^{19}$ molecules/cm³
 ≈ 1000 ions/cm³
 ≈ 10 electrons/cm³

Free path, effective cross-section

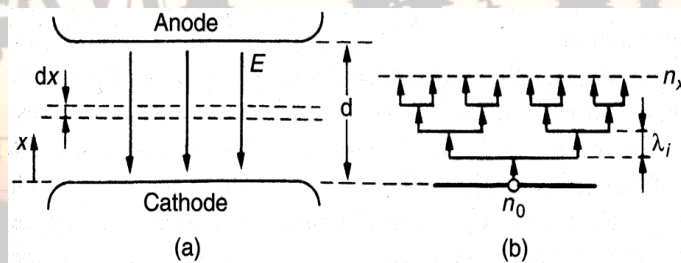
Townsend's 1st ionisation coefficient α

One electron creates α new electrons per unit length



$$n_e(x=d) = n_0 e^{\alpha d}$$

$$\alpha/p = f(E/P)$$



CAS on Small Accelerators

• Electro-negative gasses

Attachment η of electrons to ions

electrons: $n_e(x=d) = n_0 e^{(\alpha - \eta)d}$

negative ions:

$$n_-(x=d) = \frac{n_0 \eta}{\alpha - \eta} [e^{(\alpha - \eta)d} - 1]$$

Avalanche \neq Breakdown; creation of secondaries

Townsend's 2nd ionisation coefficient γ

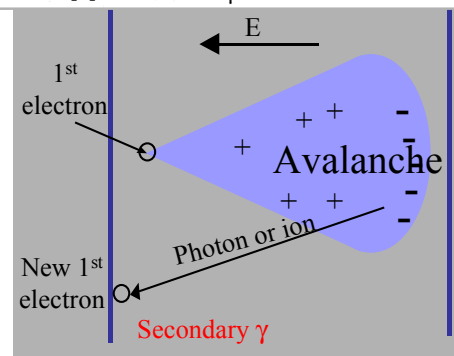
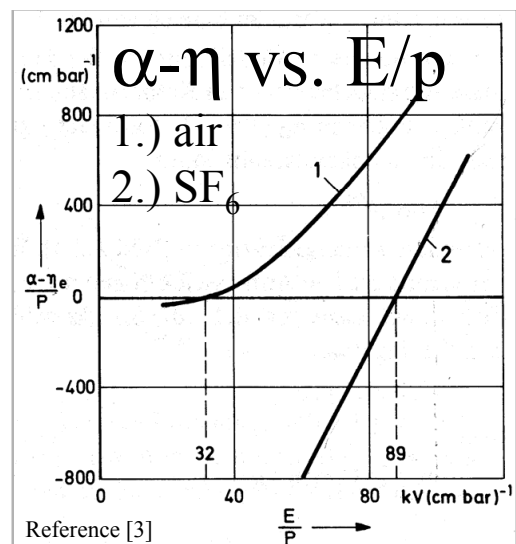
one ion or photon creates γ new electrons

at cathode $n_e = \gamma n_0 (e^{\alpha d} - 1)$

Breakdown if: # secondary electrons $\geq n_0$

$$\alpha d \geq \ln(1/\gamma + 1)$$

step function of $E/p \rightarrow e^{\alpha d}$ very steep $\rightarrow (E/p)_{critical}$ and V_d
 well defined $\rightarrow \gamma$ of weak influence



Paschen law / breakdown field

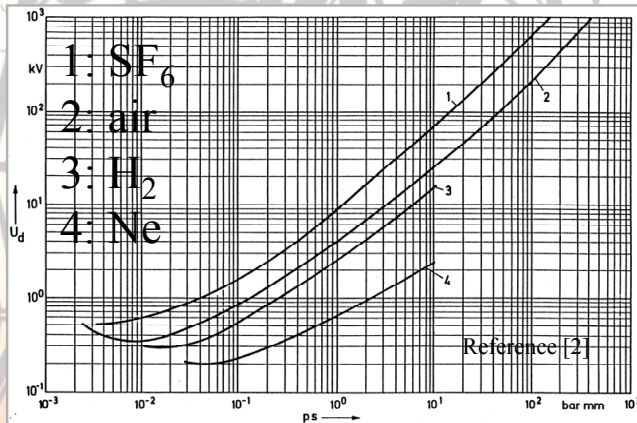
- Townsend breakdown criterion $\alpha d = K$:

$$\frac{E_d}{p} = \frac{B}{\ln(Apd/K)} \quad V_d = \frac{Bpd}{\ln(Apd/K)}$$

with $A = \sigma_I/kT$
 $B = V_I \sigma_I/kT$

→ E_d and V_d depend only on $p \cdot d$

p: pressure d: gap length



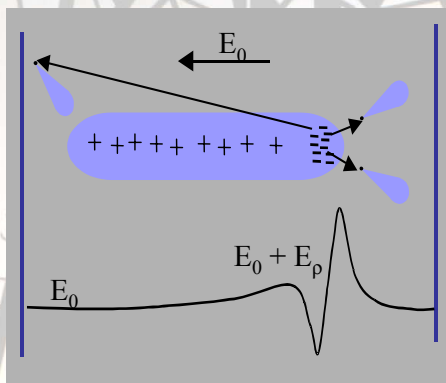
Typically practically
 $E_{bd} = 10 \text{ kV/cm}$
 at 1 bar in air

$$V_{bd, \text{Paschen min, air}} \approx 300 \text{ V}$$

- Small $p \cdot d$, $d \ll \lambda$: few collisions, high field required for ionisation
- Large $p \cdot d$, $d \gg \lambda$: collision dominated, small energy build-up, high V_d

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Streamer breakdown



Space charge field $E_p \approx E_0$

- Field enhancement
 extra ionising collisions ($\alpha \uparrow$)
- High excitation \Rightarrow UV photons
 when 1 electron grows into ca. 10^8
 then E_p large enough for streamer
 breakdown ($n_e \approx 2 \cdot 10^8$ in avalanche head)

Result:

- Secondary avalanches, directional effect (channel formation)
- Grows out into a breakdown within 1 gap crossing (anode and/or cathode directed)

Characteristic:

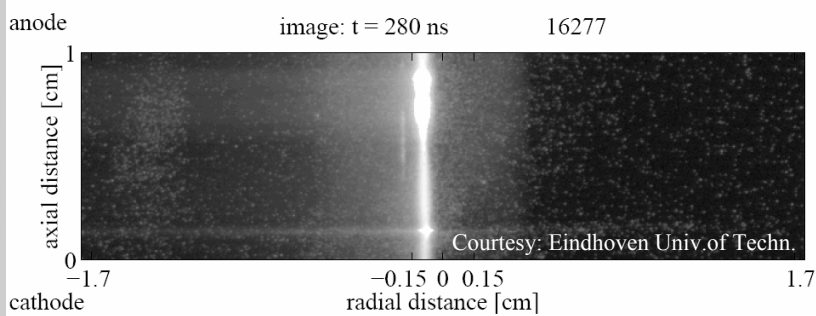
- Very fast
- Independent of electrodes (no need for electrode surface secondaries)
- Important at large distances (lightning)

CAS on Small Accelerators

→ Townsend, unless:

- Strong non-uniform field
(small electrodes, few secondary electrons)
- Pulsed voltages
 - Townsend slow, ion drift, subsequent gap transitions
 - Streamer fast, photons, 1 gap transition
- High pressure
 - Less diffusion
 - E_p high
 - photons absorbed in front of cathode
 - positive ions slower

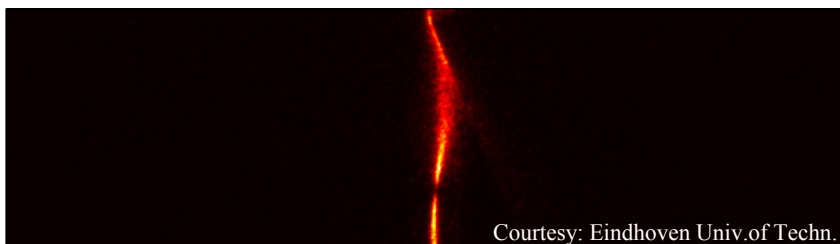
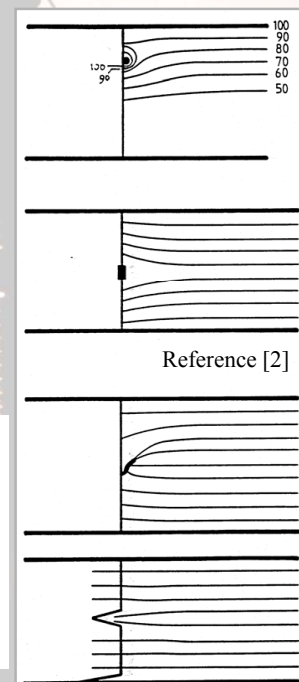
- Townsend: $\alpha d \geq \ln(1/\gamma + 1) \approx 7...9$
($\gamma \approx 10^{-4}...10^{-3}$)
- Streamer: $\alpha d \geq 18...20$



Laser-induced streamer breakdown in air.

Breakdown along insulator

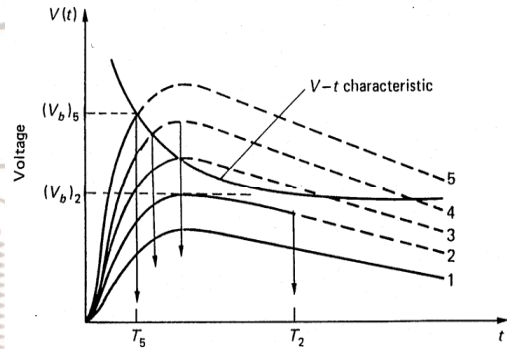
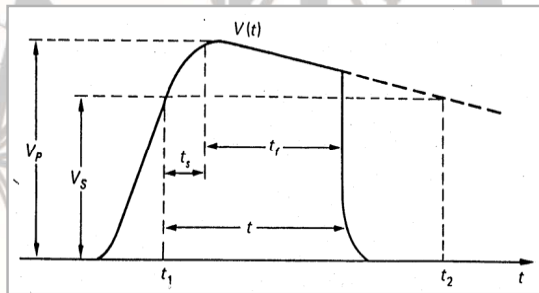
- Surface charge
 - (Non-regular) surface conduction
 - Particles / contaminations on surface
 - Non-regularities (scratches, ridges)
- ⇒ Field enhancement
⇒ Increased breakdown probability



Courtesy: Eindhoven Univ. of Techn.

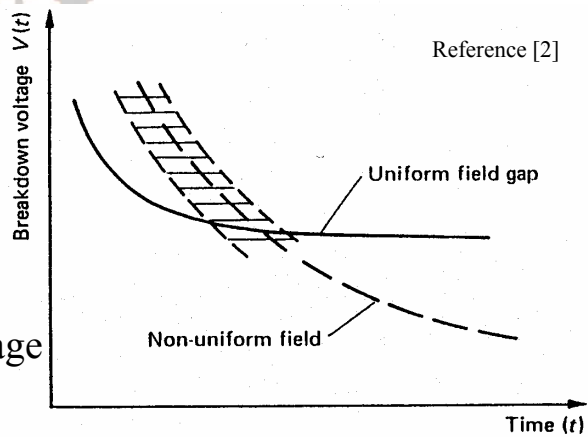
Prebreakdown along insulator in air.

Breakdown at pulse voltages; time-lag



- t_s , wait for first elektron
- t_f , breakdown formation
- Townsend or Streamer

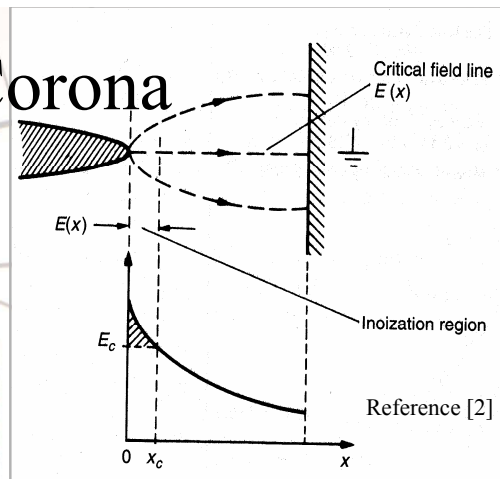
Short pulses, high breakdown voltage



Non-uniform fields; Corona

Breakdown conditions:

- Global → Full breakdown
- Local → Streamer breakdown
- Partial discharge



Non-uniform field:

- Discharge starts in high field region
- ...and “extinguishes” in low field region



Corona

- Power loss; EM noise
- Chemical corrosion
- + Useful applications

Pulsed corona discharges:

- Fast, short duration HV pulses
- Many streamers, high density
- Generation of electrons, radicals, excited molecules, UV
- E.g. Flue gas cleaning

Courtesy: Eindhoven Univ. of Techn. 40 ns

Transmission line transformer

CAS on Small Accelerators

Solid insulation

Breakdown field strength:

- Very clean (lab): high
- Practical: lower due to imperfections
 - Voids
 - Absorbed water
 - Contaminations
 - Structural deformations

Requirements:

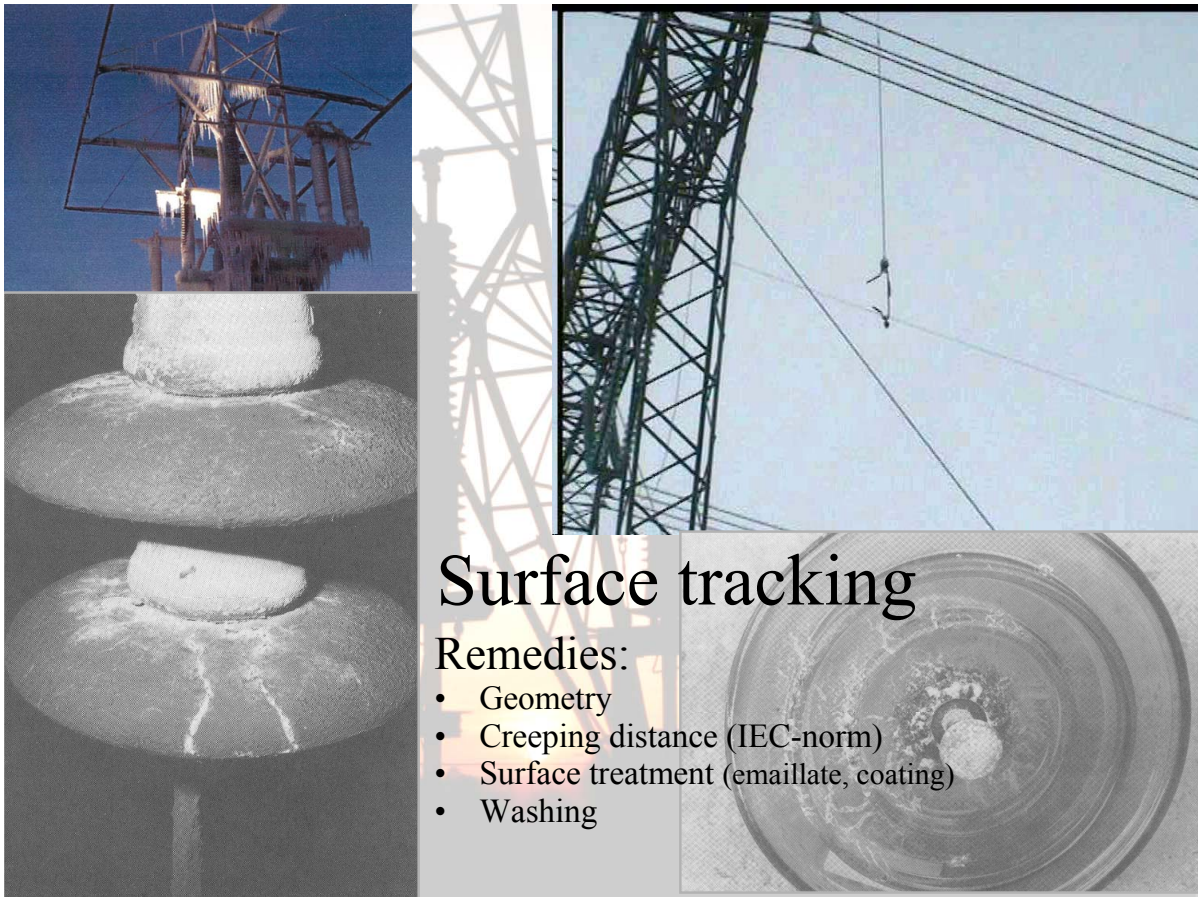
- Mechanical strength
- Contact with electrodes and semiconducting layers
- Resistant to high T, UV, dirt, contamination, rain, ice, desert sand

| | | |
|--|---|--|
| Anorganic Natural Synthetic | Quartz,mica,glas Porcelain Al_2O_3 | Disc insulator Feedthrough Spacer |
| Paper + Oil | | Cable Capacitor |
| Synthetic Organic Polymerisation | Polyethelene HD,LD,XL – PE Teflon Polystyrene, PVC, polypropene,etc | Spec. properties: Moisture content high T losses bonding |
| Epoxy | Hardener Filler | Moulding in mold |

Problems:

- Surface tracking
- Partial discharges
 - In voids
(in material or at electrodes,
often created at production).

Types of solid insulation materials



Surface tracking

Remedies:

- Geometry
- Creeping distance (IEC-norm)
- Surface treatment (emaillate, coating)
- Washing



Vacuum insulation

Applications:

- Vacuum circuit breaker
- Cathode Ray Tubes / accelerators
- Elektron microscope
- X-ray tube
- Transceiver tube

What is vacuum?

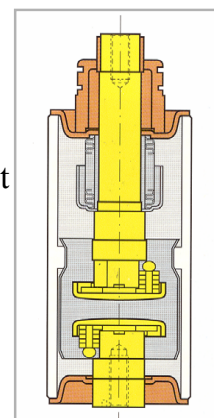
- “Pressure at which no collisions for Brownian “temperature” movements of electrons”
- $\lambda \gg$ characteristic distances
- E.g. $p = 10^{-6}$ bar, $\lambda = 400$ m

Advantages:

- “Self healing”
- No dielectric losses
- High breakdown fieldstrength
- Non flammable
- Non toxic, non contaminating

Disadvantages:

- Requires hermetic containment and mechanical support
- Quality determined by:
 - electrodes and insulators
 - Material choice, machining
 - Contaminations, conditioning



Characteristics of vacuum breakdown

No 1st electron from “gas”

- Cathode emission
 - primary: photoemission, thermic emission, field emission, Schottky-emission
 - secondary: e.g. e⁻ bombarded anode → ⁺ion collides at cathode → e⁻

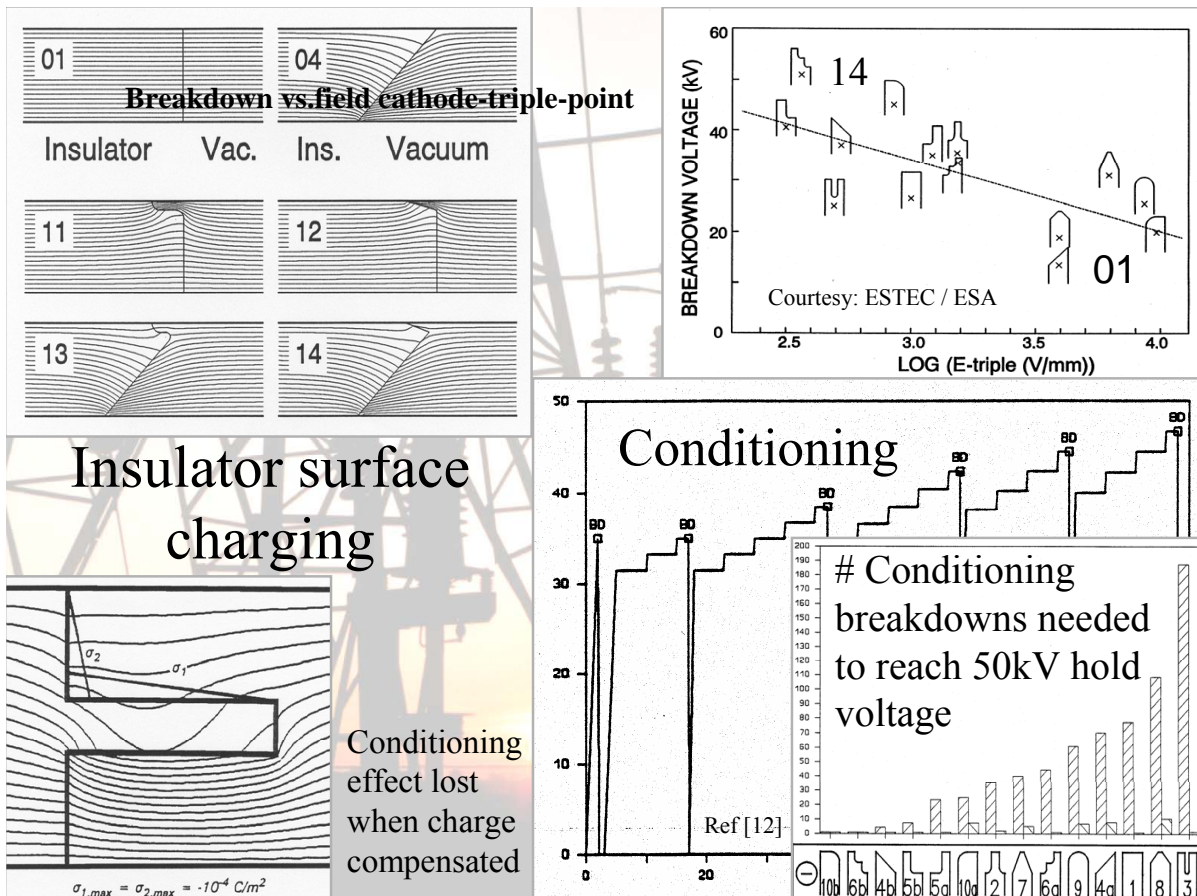
No breakdown medium

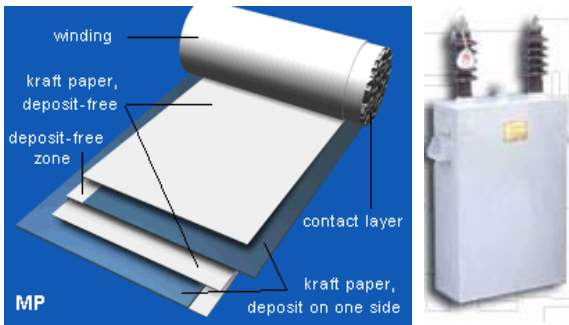
- No multiplication through collision ionisation
- Medium in which the breakdown occurs has to be created (“evaporated” from electrodes, insulators)

Important: prevent field emission

- Keep field at cathode and “cathode triple point” as low as possible
- Insulator surface charging, conditioning

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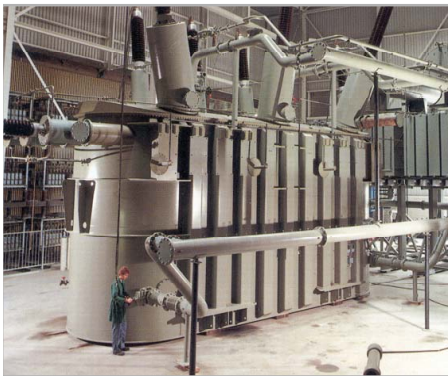
Insulating liquids

Requirements:

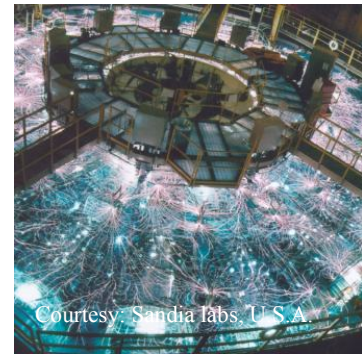
- Pure, dry and free of gases
- ϵ_r (high for C's, low for trafo) (demi water $\epsilon_{r,d.c.} = 80$)
- Stable (T), non-flammable, non toxic (pcb's), ageing, viscosity

Applications:

- Transformers
- Cables
- Capacitors
- Bushings

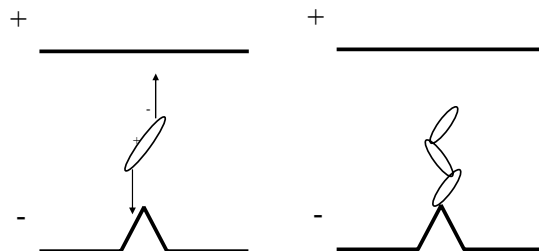


- No interface problems
- Combined cooling/insulation
- "Cheap" (no mould)
- Liquid tight housing



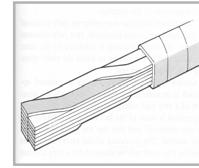
Breakdown fieldstrength:

- **Very clean (lab): high 1 - 4 MV/cm (In practice much lower)**
- **Important at production: outgassing, filtering, drying**
- **Mineral oil** ("old" time application, cheap, flammable)
- **Synthetic oil** (purer, specifically made, more expensive)
 - **Silicon oil** (very stable up to high T, non-toxic, expensive)
- **Liquid H₂, N₂, Ar, He** (supra-conductors)
- **Demi-water** (incidental applications, pulsed power)
- **Limitation V_{bd} :**
 - Inclusions: Partial discharges \rightarrow Oil decomposition \rightarrow Breakdown
 - Growth (pressure increase)
 - "extension" in field direction"
- **Particles drift** to region with highest E \rightarrow bridge formation \rightarrow breakdown



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Transformer:

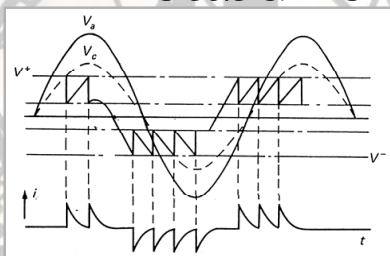


- **Mineral oil:** Insulation and cooling
- **Paper:** Barrier for charge carriers and chain formation
 - Mechanical strength
- **Ageing**
 - Thermal and electrical (partial discharges)
 - Lifetime: 30 years, strongly dependent on temperature, short-circuits, over-loading, over-voltages
 - Breakage of oil molecules, Creation of gasses, Concentration of various gas components indication for exceeded temperature (as specified in IEC599)
- **Lifetime**
 - Time in which paper loses 50 % of its mechanical strength
 - Strongly dependent on:
 - Moisture (from 0.2 % to 2 % accelerated ageing factor 20)
 - Oxygen (presence accelerates ageing by a factor 2)

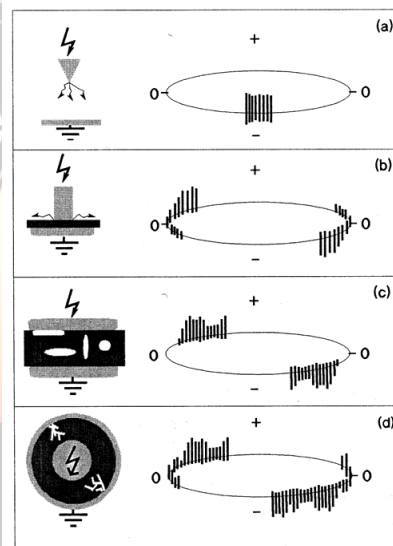


Measurement techniques

Partial discharges



- UV, fast electrons, ions, heat
- Deterioration void:
 - Oxidation, degradation through ion-impact
 - “Pitting”, followed by treeing
- Eventually breakdown



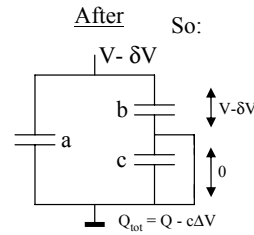
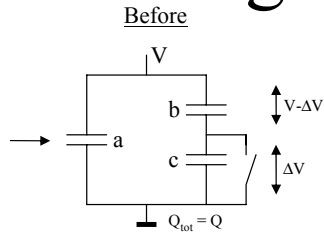
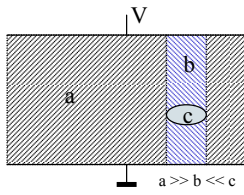
Acceptable lifetime? Preferably no partial discharges.

- High sensitivity measurements on often large objects
- $Q_{app} \neq Q_{real}$, still useful, because measure for dissipated energy, thereby for induced damage
- relative measurement

AC voltage phase resolved discharge pattern detection → Type of defect

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Partial discharges



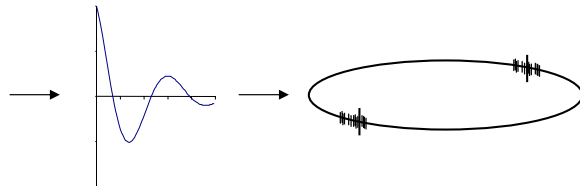
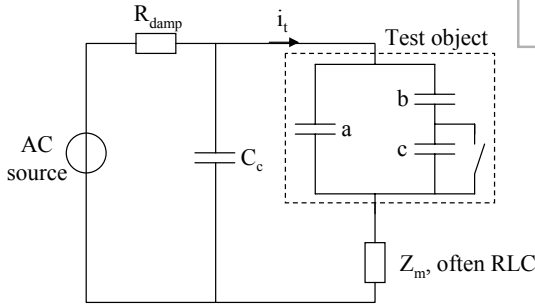
Before: $Q = aV + b(V - \Delta V) + c \Delta V$
 After: $Q - c \Delta V = (a + b)(V - \delta V)$

So: $c \Delta V = a \delta V + b(\delta V - \Delta V) + c \Delta V$
 $\delta V = \Delta V \frac{b}{(a+b)} \approx \Delta V \frac{b}{a}$

Apparent charge:
 $C_{tot} \delta V = (a + bc/(b+c)) \delta V$
 $\approx (a+b) \delta V \approx a \delta V$

$\frac{Q_{app}}{Q_{real}} = \frac{a \delta V}{c \Delta V} = \frac{b \Delta V}{c \Delta V} = \frac{b}{c} \approx \frac{\epsilon_r d_{void}}{d_{insul}}$

High sensitivity measurement because $b/c \ll 1$



- Q_{app} gives i_t ($Q_{app} = \int i_t dt$)
- C_c gives i_t if $C_c \gg C_{object}$
- Calibration through injecting known charge

- Measure with resonant RLC circuit:
 - Excitation by short pulse i_t
 - No 50 Hz problem
 - $V = q/C \exp(-\alpha t) \{ \cos \beta t - \alpha/\beta \sin \beta t \}$
 - $\alpha = 1/(2RC)$ $\beta = [1/(LC) - \alpha^2]^{1/2}$

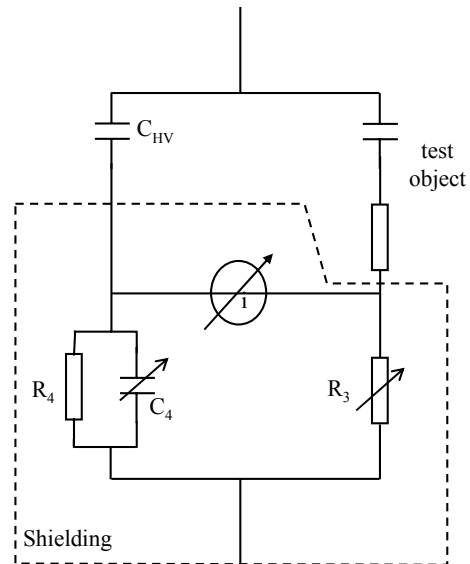
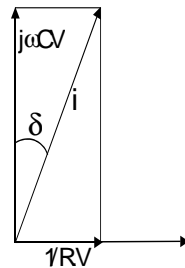
Loss angle, $\tan(\delta)$

Sources:

- Conduction σ (for DC or LF)
- Partial discharges
- Polarisation

Schering bridge:

- $i=0$, $RC=R_4C_4$
- Gives: $\tan(\delta)$
 - parallel: $1/\omega RC$
 - serie: ωRC

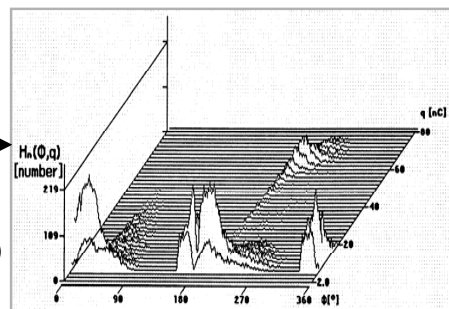
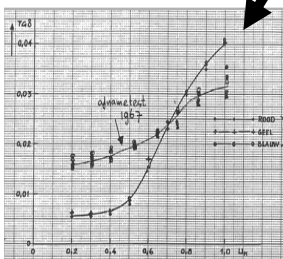


Tan δ :

- "Bulk" parameter
- No difference between phases

PD:

- Detection of weakest spot
- Largest activity and asymmetry in "blue" phase (ridge discharges)



Summary

Seen many basic high voltage engineering technology aspects here:

- High voltage generation
- Field calculations
- Discharge phenomena

The above to be applied in your practical accelerator environments as needed:

- Vacuum feed through: Triple points
- Breakdown field strength in air 10kV/cm
- Challenging calculations for real practical geometries.

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Appendix I

Maxwell equations in integral form

$$\oiint \vec{D} \cdot d\vec{A} = \iiint \rho \, dV = Q_{omst.} \quad \text{Electrostatic} \quad \oiint \vec{D} \cdot d\vec{A} = Q_{omst.} \quad (1)$$

$$\oint \vec{E} \cdot d\vec{l} = -\frac{d}{dt} \iint \vec{B} \cdot d\vec{A} = -\frac{d\phi_{omst.}}{dt} \quad \oint \vec{E} \cdot d\vec{l} = 0 \quad (2)$$

$$\oiint \vec{B} \cdot d\vec{A} = 0 \quad \text{Magnetostatic} \quad \oiint \vec{B} \cdot d\vec{A} = 0 \quad (3)$$

$$\oint \vec{H} \cdot d\vec{l} = \iint (\vec{J} + \frac{\partial \vec{D}}{\partial t}) \cdot d\vec{A} \quad \oint \vec{H} \cdot d\vec{l} = I_{omst.} \quad (4)$$



Maxwell equations in differential form

$$\vec{\nabla} \cdot \vec{D} = \rho \quad \text{Electrostatic} \quad \vec{\nabla} \cdot \vec{D} = \rho \quad \text{No space charge} \quad \vec{\nabla} \cdot \vec{D} = 0 \quad (5)$$

$$\vec{\nabla} \times \vec{E} = -\frac{\partial \vec{B}}{\partial t} \quad \vec{\nabla} \times \vec{E} = 0 \quad \vec{\nabla} \times \vec{E} = 0 \quad (6)$$

$$\vec{\nabla} \cdot \vec{B} = 0 \quad \text{Magnetostatic} \quad \vec{\nabla} \cdot \vec{B} = 0 \quad \text{In area without source} \quad \vec{\nabla} \cdot \vec{B} = 0 \quad (7)$$

$$\vec{\nabla} \times \vec{H} = \vec{J} + \frac{\partial \vec{D}}{\partial t} \quad \vec{\nabla} \times \vec{H} = \vec{J} \quad \vec{\nabla} \times \vec{H} = 0 \quad (8)$$

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Appendix III Finite Element Method (FEM)

Field energy minimal inside each closed region G:

$$W = \int \frac{1}{2} \epsilon |\vec{E}|^2 \, dV = \int \frac{1}{2} \epsilon |\nabla U|^2 \, dV$$

Assume U satisfies Laplace equation, but U' does not, then

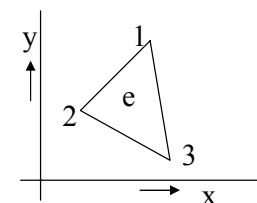
$$W_{U'} - W_U \geq 0:$$

$$W_{U'} - W_U = \frac{1}{2} \epsilon \iiint_G (|\nabla U'|^2 - |\nabla U|^2) \, dV = \dots = \frac{1}{2} \epsilon \iiint_G |\nabla U' - \nabla U|^2 \, dV \geq 0$$

Field energy for one element (2-dim)

Potential is linear inside element: $U = a + bx + cy = \begin{pmatrix} 1 & x & y \end{pmatrix} \begin{pmatrix} a \\ b \\ c \end{pmatrix}$

on corners: $\begin{pmatrix} U_1 \\ U_2 \\ U_3 \end{pmatrix} = \begin{pmatrix} 1 & x_1 & y_1 \\ 1 & x_2 & y_2 \\ 1 & x_3 & y_3 \end{pmatrix} \begin{pmatrix} a \\ b \\ c \end{pmatrix}$



Potential can be written as:

$$U = \begin{pmatrix} 1 & x & y \end{pmatrix} \begin{pmatrix} 1 & x_1 & y_1 \\ 1 & x_2 & y_2 \\ 1 & x_3 & y_3 \end{pmatrix}^{-1} \begin{pmatrix} U_1 \\ U_2 \\ U_3 \end{pmatrix} = \sum_{i=1}^3 U_i \alpha_i(x, y)$$

Field energy in element (e):

$$W^{(e)} = \frac{1}{2} \epsilon U^T [S^{(e)}] U \quad \text{with} \quad S_{ij}^{(e)} = \iint (\nabla \alpha_i \cdot \nabla \alpha_j) \, dx dy$$

α 's are linear in x and $y \Rightarrow \nabla \alpha$ is constant: $S_{ij} = (\nabla \alpha_i \cdot \nabla \alpha_j) A^{(e)}$

Total field energy of n elements

All elements together:
$$U^T = (U_1 \ \dots \ U_m \ U_{m+1} \ \dots \ U_n) \equiv (U_f \ U_p)$$

free *prescribed*

free: potential values to be determined

prescribed: potential according to boundary conditions

$$W = \frac{1}{2} \epsilon U^T [S] U = \frac{1}{2} \epsilon \begin{bmatrix} U_f^T & U_p^T \end{bmatrix} \begin{bmatrix} S_{f'f'} & S_{f'p'} \\ S_{p'f'} & S_{p'p'} \end{bmatrix} \begin{bmatrix} U_f \\ U_p \end{bmatrix}$$

Partial derivatives of W to U_k are zero for $1 \leq k \leq m$ (m equations):

$$\frac{\partial W}{\partial U_k} = 0 \Rightarrow \begin{bmatrix} S_{kf} & S_{kp} \end{bmatrix} \begin{bmatrix} U_f \\ U_p \end{bmatrix} = 0$$

Boundary Element Method (BEM)

Boundaries uniquely prescribe potential distribution

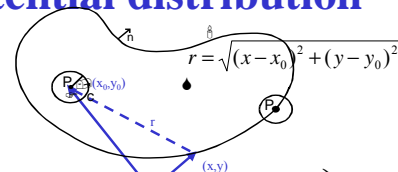
Laplace equation : $\Delta u = 0$

border $\Gamma_1 : u(x, y)$ (Dirichlet)

border $\Gamma_2 : q(x, y) \equiv \frac{\partial u}{\partial n}$ (Neumann)

$P_0 = (x_0, y_0)$ inside Γ :
$$u(x_0, y_0) = \frac{1}{2\pi} \oint_{\Gamma} \left(u(x, y) \frac{\partial \ln r}{\partial n} - q(x, y) \ln r \right) ds$$

Problem: $u(x,y)$ and $q(x,y)$ not both known at the same time



Green II (2-dim):

$$\oint (u \nabla v - v \nabla u) \cdot \hat{n} ds = \iint (u \Delta v - v \Delta u) dx dy$$

Choose $v(x,y) = \ln(1/r)$

$$\Delta v(x,y) = 0 \text{ for } P \neq P_0(x_0, y_0)$$

Exclude region σ around P_0 by means of circle c

$$\oint_{\Gamma + c} \left(u \frac{\partial \ln r^{-1}}{\partial n} - \ln r^{-1} \frac{\partial u}{\partial n} \right) ds = \iint_{\Omega - \sigma} (u \Delta \ln r^{-1} - \ln r^{-1} \Delta u) dx dy = 0$$

$$-\oint_{\Gamma} \left(u \frac{\partial \ln r}{\partial n} - \ln r \frac{\partial u}{\partial n} \right) ds + \oint_c \left(u \frac{\partial \ln r^{-1}}{\partial n} - \ln r^{-1} \frac{\partial u}{\partial n} \right) ds = 0$$

$$\lim_{\epsilon \downarrow 0} \int_0^{2\pi} \left(u \frac{1}{\epsilon} + \frac{\partial u}{\partial n} \ln \epsilon \right) \epsilon d\vartheta = 2\pi u(x_0, y_0)$$

$P_i = (x_i, y_i)$ on border Γ :
$$u(x_i, y_i) = \frac{1}{\pi} \oint_{\Gamma} \left(u(x, y) \frac{\partial \ln r}{\partial n} - q(x, y) \ln r \right) ds$$

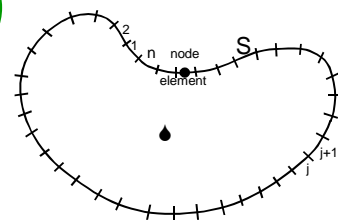
Discretisation:

$$\pi U(x_i, y_i) = \sum_{j=1}^n U_j \int_{S_j} \frac{\partial \ln r_{ij}}{\partial n} ds - \sum_{j=1}^n Q_j \int_{S_j} \ln r_{ij} ds$$

In matrix notation:

$$\sum_{j=1}^n (H_{ij} - \pi \delta_{ij}) U_j = \sum_{j=1}^n G_{ij} Q_j$$

Generates missing information



Appendix II Electrical Fields

Vacuum and matter

Dielectric displacement \vec{D} Electric field strength \vec{E} Magnetic induction \vec{B} Magnetic field strength \vec{H} Ohm's law: relation between current density \vec{J} in a conductor and specific conduction $\sigma_s (=1/\rho_s)$ and electrical field \vec{E}

$$\vec{D} = \epsilon_0 \vec{E} + \vec{P} = \epsilon_0 \epsilon_r \vec{E} = \epsilon \vec{E} \quad ; \quad \vec{B} = \mu_0 (\vec{H} + \vec{M}) = \mu_0 \mu_r \vec{H} = \mu \vec{H} \quad ; \quad \vec{J} = \sigma_s \vec{E} \quad (9,10,11)$$

Polarisation \vec{P} Magnetisation \vec{M}

(Static) boundary conditions for normal (index n) and tangential (index t) field components in terms of surface charge and surface current:

$$\oiint \vec{D} \cdot \vec{dA} = Q_{omsl.} \quad \Rightarrow \quad D_{1n} - D_{2n} = \sigma \quad (12)$$

$$\oint \vec{E} \cdot \vec{dl} = 0 \quad \Rightarrow \quad E_{1t} - E_{2t} = 0 \quad (13)$$

$$\oiint \vec{B} \cdot \vec{dA} = 0 \quad \Rightarrow \quad B_{1n} - B_{2n} = 0 \quad (14)$$

$$\oint \vec{H} \cdot \vec{dl} = I_{omsl.} \quad \Rightarrow \quad H_{1t} - H_{2t} = J^* \quad (15)$$

Conservation of charge / continuity of current

Ampere's law (8) in differential form gives:

$$\vec{\nabla} \cdot (\vec{\nabla} \times \vec{H}) = \vec{\nabla} \cdot \left(\vec{J} + \frac{\partial \vec{D}}{\partial t} \right) = 0 \quad \Rightarrow \quad \vec{\nabla} \cdot \vec{J} + \frac{\partial \rho}{\partial t} = 0 \quad (16)$$

Gauss Theorem gives the integral form:

$$\oiint \left(\vec{J} + \frac{\partial \vec{D}}{\partial t} \right) \cdot \vec{dA} = 0 \quad \text{or} \quad \oiint \vec{J} \cdot \vec{dA} + \frac{\partial Q_{omsl.}}{\partial t} = 0 \quad (17)$$

Electrical potential

(6) Gradient or (scalar) potential U:

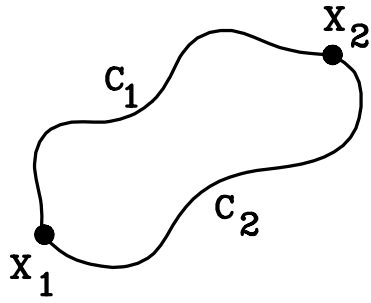
$$\vec{\nabla} \times \vec{E} = \vec{0} \quad \text{define} \quad \vec{E} = -\vec{\nabla} U \quad \Rightarrow \quad U(x) = - \int_{x'(U=0)}^x \vec{E} \cdot \vec{dl} \quad (21)$$

$$\vec{\nabla} \cdot \vec{E} = -\vec{\nabla} \cdot \vec{\nabla} U = -\Delta U \quad \text{so} \quad \Delta U = -\frac{\rho}{\epsilon} \quad (\text{Poisson}) \quad (22)$$

$$\text{Without space charge: } \Delta U = 0 \quad (\text{Laplace}) \quad (23)$$

Equations define every position in space between potential and charge distribution, given the boundary conditions.

Definition of potential only valid in the absence of varying magnetic induction. If $\partial B/\partial t \neq 0$ no more (scalar) potentials, only voltage differences, which have become dependent on the path (non-conservative field):



$$\int_{C_1} \vec{E} \cdot d\vec{l} - \int_{C_2} \vec{E} \cdot d\vec{l} = \oint \vec{E} \cdot d\vec{l} = -\frac{d}{dt} \iint \vec{B} \cdot d\vec{A} \quad (24)$$

or

$$[V_1 - V_2]_{\text{via } C_1} - [V_1 - V_2]_{\text{via } C_2} \neq 0 \quad (25)$$

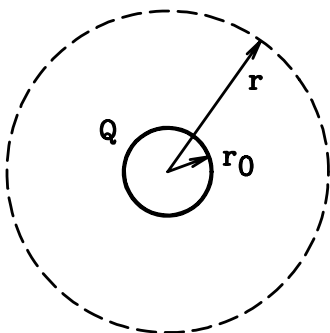
Analytical methods

Gauss' law in integral form (1), charges \rightarrow E-field (and potential) for configuration.
Potential equations (22) or (23) for given boundary conditions \rightarrow potential and E-field.

| Fields from charges | | Fields from Potentials | |
|---------------------|---------------|------------------------|--|
| Q and Gauss' law | \Rightarrow | E | Laplace / Poisson + boundary (V) \Rightarrow U |
| Integration of E | \Rightarrow | U | Differentiation of U \Rightarrow E |
| U on boundary | \Rightarrow | V | E and Gauss' law \Rightarrow Q |
| V and Q | \Rightarrow | C | Q and V \Rightarrow C |

Fields from charges

Gauss' law, electrical field coupled to charge.
Two concentric spheres:



$$\oiint \epsilon_0 \epsilon_r \vec{E} \cdot d\vec{A} = Q \Rightarrow E = \frac{Q}{4\pi \epsilon_0 \epsilon_r r^2} \quad (26)$$

$$U(r) = -\int E(r) dr = \frac{Q}{4\pi \epsilon_0 \epsilon_r r} + \text{Integration constant} \quad (27)$$

Potential in infinity zero \rightarrow

$$U(r) = \frac{Q}{4\pi \epsilon_0 \epsilon_r r}$$

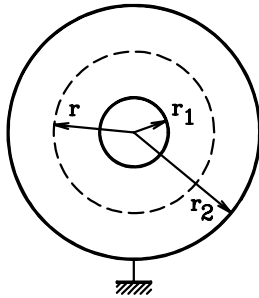
Capacity of sphere with radius r_0 :

$$C = \frac{Q}{U(r_0)} = \frac{Q}{V} = 4\pi \epsilon_0 \epsilon_r r_0 \quad (29)$$

Field maximum on sphere surface:

$$E_{\max} = E(r_0) = \frac{Q}{4\pi\epsilon_0\epsilon_r r_0^2} = \frac{V}{r_0} \quad (30)$$

Concentric metal spheres



$$U(r) = \frac{Q}{4\pi\epsilon_0\epsilon_r} \left[\frac{r_2 - r}{r_2 r} \right] \quad (r_1 \leq r \leq r_2) \quad (31)$$

$$C = 4\pi\epsilon_0\epsilon_r \frac{r_1 r_2}{r_2 - r_1} \quad (32)$$

Maximum field on surface inner sphere:

$$E_{\max} = E(r_1) = \frac{V}{r_1(1 - r_1/r_2)} \quad (33)$$

Concentric cylinders

Two concentric cylinders with inner radius r_1 and outer radius r_2 :

$$E(r) = \frac{Q/l}{2\pi\epsilon_0\epsilon_r r} \Rightarrow U(r) = \frac{Q/l}{2\pi\epsilon_0\epsilon_r} \cdot \ln(r_2/r) \quad (34)$$

$$C/l = \frac{2\pi\epsilon_0\epsilon_r}{\ln(r_2/r_1)} \quad (35)$$

$$E_{\max} = \frac{V}{r_1 \ln(r_2/r_1)} \quad (36)$$

Fields from potential equations

Poisson equation or (without space charge, $\rho = 0$) Laplace:

$$\text{Poisson: } \Delta U = -\frac{\rho}{\epsilon} \quad (37)$$

$$\text{Laplace: } \Delta U = 0$$

General solution + boundary conditions \rightarrow specific solution.

Differentiation gives E-field, applying Gauss gives the charge. From charge and voltage \rightarrow capacity.

Laplace equation in Cartesian, cylindrical or spherical coordinates:

$$\begin{aligned}
 \text{Cartesian : } & \frac{\partial^2 U}{\partial x^2} + \frac{\partial^2 U}{\partial y^2} + \frac{\partial^2 U}{\partial z^2} = 0 \\
 \text{Cylindrical : } & \frac{1}{r} \frac{\partial}{\partial r} \left[r \frac{\partial U}{\partial r} \right] + \frac{1}{r^2} \frac{\partial^2 U}{\partial \vartheta^2} + \frac{\partial^2 U}{\partial z^2} = 0 \\
 \text{Sphere : } & \frac{1}{r^2} \frac{\partial}{\partial r} \left[r^2 \frac{\partial U}{\partial r} \right] + \frac{1}{r^2 \sin \vartheta} \frac{\partial}{\partial \vartheta} \left[\sin \vartheta \frac{\partial U}{\partial \vartheta} \right] + \frac{1}{r^2 \sin^2 \vartheta} \frac{\partial^2 U}{\partial \varphi^2} = 0
 \end{aligned} \tag{38}$$

Concentric spheres

Two concentric metal spheres. Only r-dependent (38):

$$\begin{aligned}
 \frac{1}{r^2} \frac{\partial}{\partial r} \left[r^2 \frac{\partial U}{\partial r} \right] = 0 & \Rightarrow \frac{\partial U}{\partial r} = \frac{C_1}{r^2} \Rightarrow U = -\frac{C_1}{r} + C_2 \\
 \text{and } E = -\frac{C_1}{r^2} &
 \end{aligned} \tag{45}$$

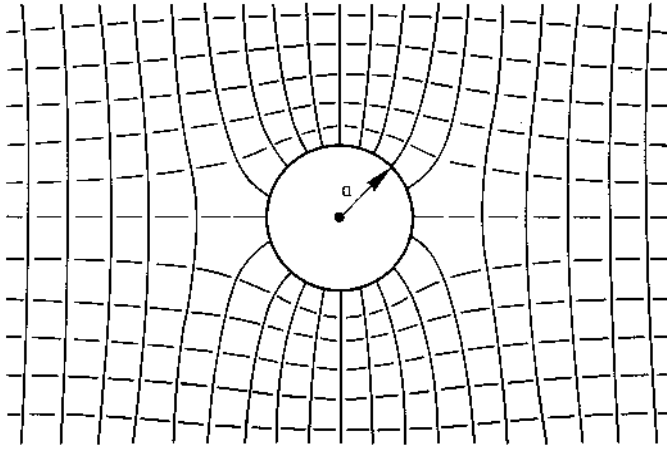
→ Result: spherical equipotential surfaces. With boundary conditions on inner sphere $U(r_1) = V$ and on outer sphere $U(r_2) = 0$:

$$U = \frac{r_1}{r} \left(\frac{r_2 - r}{r_2 - r_1} \right) V \quad \text{and} \quad E = \left(\frac{r_1 r_2}{r_2 - r_1} \right) \frac{V}{r^2} \tag{46}$$

Charge on the sphere Q and $C = Q/V$:

$$Q = \oiint \epsilon_0 \epsilon_r \vec{E} \cdot \vec{dA} = 4\pi \epsilon_0 \epsilon_r \left(\frac{r_1 r_2}{r_2 - r_1} \right) V \quad \text{and} \quad C = 4\pi \epsilon_0 \epsilon_r \left(\frac{r_1 r_2}{r_2 - r_1} \right) \tag{47}$$

Cylinder in a uniform field



$$U = -E_0 r \cos \vartheta = -E_0 x \quad (48)$$

$$U(r) = -E_0 r \cos \vartheta + \sum_{m=1}^{\infty} d_m r^{-m} (g_m \cos(m\vartheta) + h_m \sin(m\vartheta)) \quad (49)$$

$$U(r, \vartheta) = -E_0 \left(r - \frac{a^2}{r} \right) \cos \vartheta \quad (50)$$

$$E_r = -\frac{\partial U}{\partial r} = E_0 \left(1 + \frac{a^2}{r^2} \right) \cos \vartheta \quad \text{and} \quad E_\vartheta = -\frac{1}{r} \frac{\partial U}{\partial \vartheta} = -E_0 \left(1 - \frac{a^2}{r^2} \right) \sin \vartheta \quad (51)$$

Maximum field $2 \cdot E_0$ at $(r, \theta) = (a, 0)$ and the tangential field is zero on $r = a$.

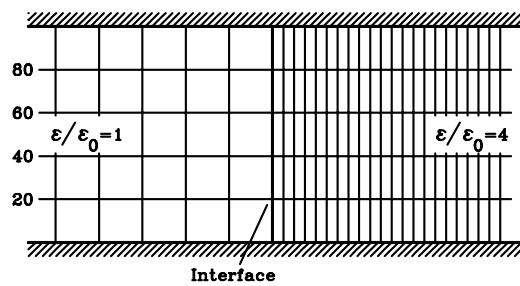
Fields from transformations

Graphical method

The graphical method uses properties as described more extensively in Alston [4].

Example:

1. Draw E-lines and U-lines in uniform area.
2. Divide U in equal partitions
3. Choose a “mesh factor”.
4. Draw the “guessed” U-lines in the non-uniform area, which fit continuously to those in the uniform area.
5. Now draw the E-lines such that the mesh factor is respected.
6. Correct where necessary the U-lines, repeat the procedure with the E-lines, and refine if needed.

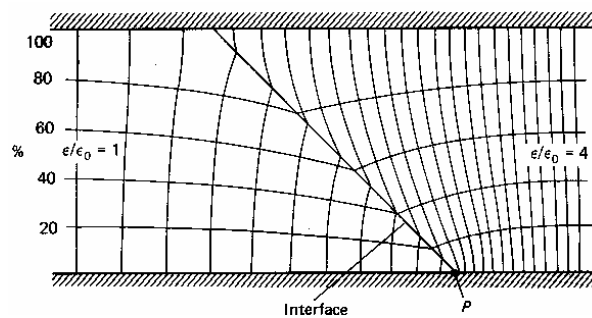
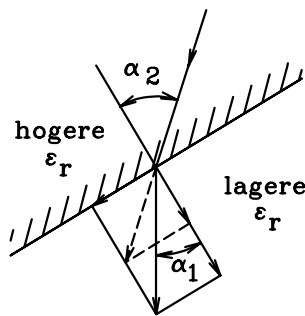


For areas with different dielectrics ϵ_r , the mesh factor changes (see example above). Since the field lines are drawn on equal flux distances $\delta\psi$ we in fact draw D-lines.

On an interface between dielectrics we in addition get dielectric refraction.

On the interface E_t and D_n are continuous \rightarrow

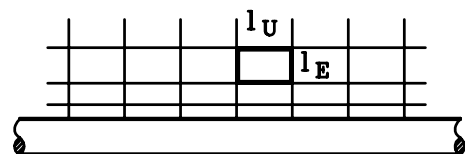
$$\frac{\tan \alpha_1}{\tan \alpha_2} = \frac{\epsilon_{r1}}{\epsilon_{r2}} \quad (55)$$



The field becomes non-uniform, with field enhancement at point P.

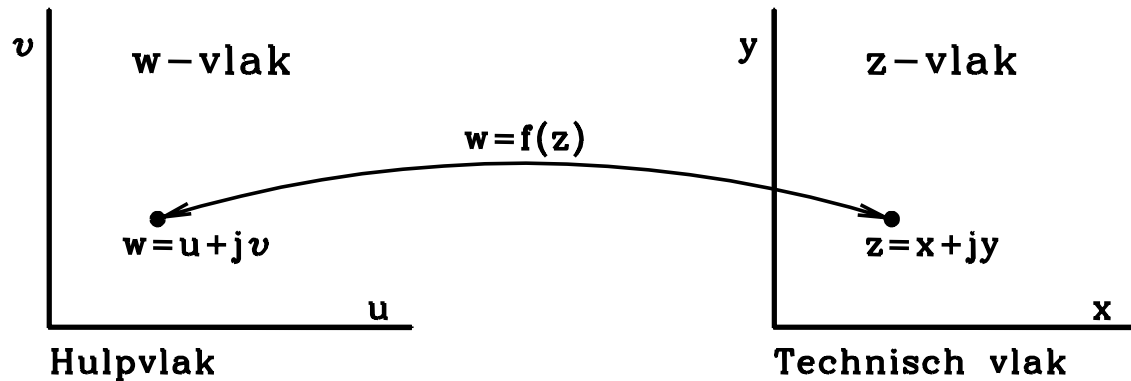
For rotational symmetry we have to replace de constant l_z by $2\pi r$:

$$\frac{\epsilon_r l_U r}{l_E} = \frac{1}{2\pi\epsilon_0} \frac{\delta\psi}{\delta U} = constant \quad (56)$$



Conformal mapping

Conformal mapping is a mathematical method to determine E-fields in two dimensional, z-independent cases (see Binns [5] or Feynman [6]). We consider a complex analytical function $f(z)$ of the complex variable z ; i.e. a function for which in an area both $f(z)$ and its derivative $f'(z)$ exist. Complex function theory shows the transformation defined by $f(z)$ to be conformal, except for those points where the derivative $f'(z)$ equals zero (see e.g. Kreyszig [7]). Conformal mapping assumes the transformed angles to be “conform”. We will use this property to transform a E-U field to a different pattern which again we can interpret as a E-U plot.



A mathematical help surface, the w-surface with coordinates u and v , is projected onto the “technical” z-surface, with coordinates x and y , for which we want to obtain a field.

Consider the coordinates: $z = x + jy$ and $w = f(z) = u + jv$, with x and y on the technical surface and u and v on the mathematical surface.

For a function $f(z)$ with which the z-surface is projected onto the w-surface we can show:

$$f'(z) = \lim_{\Delta z \rightarrow 0} \frac{f(z + \Delta z) - f(z)}{\Delta z} \Rightarrow f'(z) = \frac{\partial u}{\partial x} + j \frac{\partial v}{\partial x} \quad \text{and} \quad f'(z) = -j \frac{\partial u}{\partial y} + \frac{\partial v}{\partial y} \quad (59)$$

The first for $\Delta z \rightarrow 0$ for $\Delta y = 0$ and $\Delta x \rightarrow 0$. The second for $\Delta x = 0$ and $\Delta y \rightarrow 0$. Both derivatives are equal for an analytical function:

$$\frac{\partial u}{\partial x} = \frac{\partial v}{\partial y} \quad \text{en} \quad \frac{\partial u}{\partial y} = -\frac{\partial v}{\partial x} \quad (60)$$

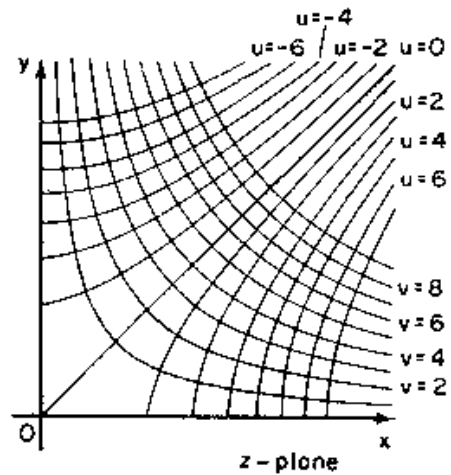
The so called Cauchy-Riemann equations.

It can be shown, for all functions that satisfy these criteria to be analytical. Both the function $u(x,y)$ as well as $v(x,y)$ fulfill the Laplace equation, as can be seen when applying Cauchy-Riemann:

$$\Delta u = \frac{\partial^2 u}{\partial x^2} + \frac{\partial^2 u}{\partial y^2} = \frac{\partial^2 v}{\partial x \partial y} - \frac{\partial^2 v}{\partial y \partial x} = 0 \quad ; \quad \Delta v = \frac{\partial^2 v}{\partial x^2} + \frac{\partial^2 v}{\partial y^2} = -\frac{\partial^2 u}{\partial x \partial y} + \frac{\partial^2 u}{\partial y \partial x} = 0 \quad (61)$$

We can interpret u as potential and v as field or vice versa. We now choose in the w-surface the simplest field projection meeting the Laplace requirement, e.g. equipotential lines $u = \text{cst}$ and E-lines $v = \text{cst}$. Every transformation of the z-surface gives a projection meeting Laplace's equation, and which we can interpret as field projection. The projection of $u = \text{cst}$ is again to be interpreted as equipotential line, and the projection of $v = \text{cst}$ as E-line, or vice versa.

The generated field projection only depends on the transformation function $w = f(z)$. See Binns [5] or Bewley [8] for a more systematical method for determining such functions, the so called Schwartz-Christoffel transformation method.



Shown here is an example for the function $w = f(z) = z^2$.

$$u + jv = (x + jy)^2 = x^2 - y^2 + 2jxy \quad (62)$$

Transformation of $u = cst$ and $v = cst$ gives the contours:

$$u = x^2 - y^2 = cst \quad \text{and} \quad v = xy = cst \quad (63)$$

These are hyperboles crossing each other under a 90° angle.

To be interpreted as two electrodes in one quadrant, under an angle of 90° : x- and y-axes together form one electrode (projection of $v = 0$), the other electrode is the projection of any other line with $v = \text{constant}$.